Application/Control No. Applicant(s)/Patent Under Reexamination 10/774,419 TAKEI ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 2818 Chuong A. Luu **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY US-6,881,058 04-2005 Kawano et al. 432/152 Α 06-2004 US-6,743,395 Fukunaga et al. 419/23 В С US-US-D US-Ε US-F US-G US-Н US-US-J US-Κ US-US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S 1 **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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